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33082M244

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Shigeru KASAI, et al.

U.S. Serial No.: 10/525,207

Group Art Unit: To Be Assigned

Filed: February 22, 2005

Examiner: To Be Assigned

For: GAS SUPPLY SYSTEM AND TREATMENT SYSTEM

SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the documents cited in the European Search Report issued for this counterpart Appln. No. EP 03 79 2832 dated February 8, 2007. According to the Annex to the Search Report, U.S. Patent Publication No. 2002/067917 is a family member of EP 1,211,333.

Applicants certify under 37 C.F.R. 1.97(e)(1) that all documents submitted herewith were cited in a communication from a foreign patent office in a counterpart foreign application no more than three months prior to the filing of this Statement. Therefore, it is respectfully urged that no fees are required for the Examiner's consideration of the documents listed in this Information Disclosure Statement.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP

By: _____

Michael A. Makuch, Reg. No. 32,263
1850 M Street, N.W., Suite 800
Washington, D.C. 20036
Telephone: (202) 263-4300
Fax: (202) 263-4329

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FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET 33082M244	SERIAL NO. 10/525,207
	APPLICANT: Shigeru KASAI, et al.	
	FILING DATE February 22, 2005	GROUP ART UNIT. To Be Assigned

U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE, IF APPROPRIATE
	AA	6,424,800	7/23/02	Kim			
	AB	2002/067917	6/6/02	Takamatsu, et al.			
	AC						
	AD						
	AE						
	AF						
	AG						

FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES NO	
	AH	EP 1 211 333	6/5/02	EPO				
	AI	EP 1 079 001	2/28/01	EPO				
	AJ							
	AK							
	AL							
	AM							
	AN							
	AO							
	AP							
	AQ							
	AR							

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

AS	
AT	

EXAMINER:	DATE CONSIDERED:
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	